



VCM 600-300-SS
Scroll-2TSind+2TSseq/400A6V
SQM-Srot1-Subcool-1Esh



Base pressure
 $1,3 \times 10^{-6}$ mbar

4TS High Temp Thermal sources (2TSind, 2TSseq)
Thickness Monitor – Substrate rotation – Substrate heating – E Shutter

Important

- 1) You can not work with VCM600 without the correct water pressure (Water RED light “OFF”)**
- 2) You can not make any evaporation before a certain vacuum level (factory preset) is reached. Reaching this level is indicated with the RED light “ON” near the source's current meters.**
- 3) Working procedure**
 - A) Connect (turn on) the water**
 - B) Start the procedure**
 - C) Finish with the procedure**
 - B) Turn water off**

Dear Customer

Thank you for purchasing the VCM 600 Vacuum Thermal Evaporator.

VCM 600 is a simple, yet powerful, unit that can help you to create thin films from metals and other materials on your substrates, by vacuum evaporation.

The compact unit incorporates the following parts:

- HIGH Vacuum TURBO Pump with a full informative controller
- Pirani – Cold Plasma Penning Pressure measurement system
- Two independent, high-current power supply units for up to 400A current intensity with soft thyristor current controllers.
- Two 600A source selection switches
- Thin film thickness Monitor (Quartz microbalance) with oscillator
- Safety interlocks for TURBO pump, water for the quartz head and for the protection of the sources.

The unit operates from an AC fused line with EU-type AC power socket:

- Voltage 220 VAC - 240 VAC / 50Hz – 60Hz
- Fuse 16A/25A
- Power 2500W/3000W

You can vent the chamber with your choice of gas (recommended DRY Air or N2) connecting the gas line to the appropriate socket located on the back panel.

The supplied rough pump is connected to the appropriate port on the back panel of VCM600 and is controlled from the VCM 600.

Parts of the system

The system is separated in two parts.

Part 1: Rack type Metal Base Unit

Inside the metallic base unit are all the components of the system:

- TURBO Vacuum Pump with pump controller
- Pirani – Cold Plasma Penning Head with controller
- Two, independent, high-current Power supply units for up to 400A current intensity
- Current regulators - Current indicators
- 600A source selection switches
- Thin film thickness Monitor (Quartz microbalance) with oscillator
- Vent Valve
- Shutter control
- Substrate rotation control
- Safety interlocks for TURBO and filament protection

On top of the metallic base is the SS base plate with 6x high current, water-cooled OFHC copper electrodes, free ports and threaded holes.

Part 2: Stainless Steel Vacuum chamber with accessories



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Rack type vacuum evaporator

Parts of the system



The rack
front face



The rack inside

VCM 600-300-SS

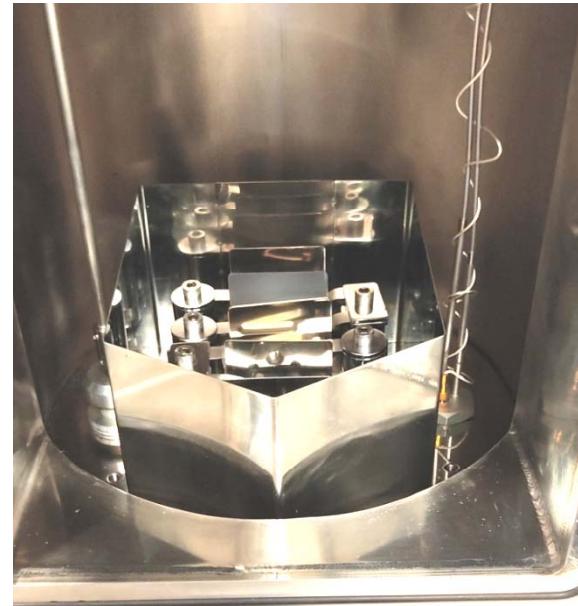
2TSind+2TSseq/400A6V-SQM-Srot1-Subcool-1Esh

Rack type vacuum evaporator

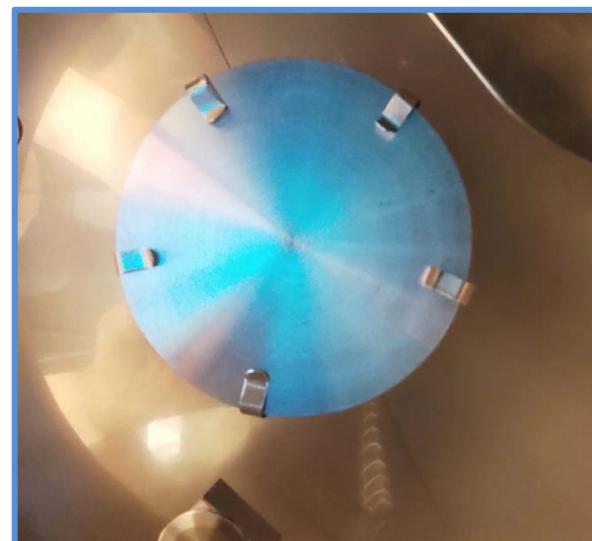
Parts of the system



Base Plate with four
High-Temp thermal sources



With No1 protector



Substrate holder
E/M shutter
Quartz crystal head

Controls and indicators on the front and the rear panel of the system

On the front panel the following controls are present:

- Main Power switch
- Heating power fuses
- Rough-pump switch
- Turbo-pump Start – Stop control (ON TURBO CONTROLLER)
- 2x Thermal source selection switches
- 2x Source current control knob
- 2x Source current indicator
- Thickness Monitor Controller
- Shutter Control switch
- Substrate rotation control
- Vent Valve control knob

The following indicators are present:

- Main Power Green Light
- Rough-pump power Green Light
- The screen on Vacuum system controller with information on Turbo-pump and Pressure value
- Evaporation Sources ON Red Light
- Source Current meters (one for each source)
- Thin film thickness on SQM160
- RED light (when ON indicates no water pressure)



On the rear panel of VCM 600 are:

- The power cable with EURO plug
- The rough-pump power socket / power cable
- The rough-pump connection port
- The vent port
- The cooling water ports and the pressure regulator

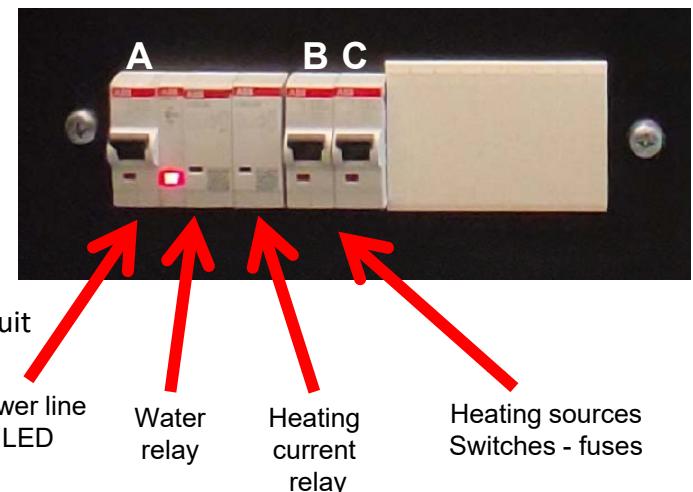


The Relay and fuses bank

A Power Line fuse-switch

B, C Fuses-switches
for High-temp thermal sources

These switches-fuses allow
heating current in each heating circuit
Move A, B, C to the "UP" position
to allow the heating current in each circuit



Important

- 1) You can not work with VCM600 without the correct water pressure
- 2) You can not make any evaporation before a certain vacuum level (factory preset) is reached.
Reaching this level is indicated with the RED light "ON" near the source's current meters.

How to start the system

- Connect the water line and adjust the pressure (typ. 2.0bar, maximum 3 BAR)
- Connect the rough-pump to VCM
 - Connect the vacuum tube to the appropriate port.
 - Connect the power cable to the rough-pump
- Connect the VCM600 to the power network. The RED LED indicate presence of power.
- Turn the Main switch to “ON”.
- Allow Vacuum controller to boot
- VCM600 is ready for operation

To perform an evaporation

- Connect the rough-pump to the rough-pump port
- Insert the rough-pump plug into the socket
- Place the aluminum pieces on the thermal source
- Place the sample on the substrate holder
- Connect VCM600 to the water line and adjust the pressure (typ 2,0bar Max 3bar)
- Start the system by turning the power switch on
- Start the rough pump by turning the rough pump switch on
- The green light indicates the existence of the power
- The pressure shown on the vacuum indicator moves to lower values
- As soon as the pressure falls lower than 7 mbar press START on TURBO Pump CONTROLLER and start the Turbopump
- As soon as the pressure falls below a preset pressure value, the POWER indicator lights up, and the heating section turns on
- This is an indication that a good vacuum level has been achieved to start the evaporation
- It is recommended to wait until the best possible Vacuum level achieved, as in this case, the quality of the film will be much better.

To perform the evaporation (cont.)

- VCM 600 can achieve, very fast, vacuum in the range of $1 \times 10 \text{ EXP}(-5)$ mbar, and after a short time, the system drops to $5 \times 10 \text{ EXP}(-6)$ mbar.
- Select the heating source using the source switch
- By activating the current control knob, make sure that the correct current intensity passes through the source.
The Current Meter displays the current value in Amps
- Soft SCR control of the current intensity allows control on the source's temperature and of the deposition rate, helping produce a high-quality film
- The maximum source temperature varies according to the material of the source from 1600 Celsius to 1800 Celsius

Upon finishing evaporation

- Minimize the current
- Turn OFF the Turbo Pump by pressing the STOP on TURBO controller
- Turn OFF Rough Pump
- Wait until TURBO PUMP stops completely
- Start venting the chamber, activating the Vent Valve.
Turn vent valve knob 3 to 4 turns to the left.
- We recommend using Nitrogen for venting the chamber.
This prevents the oxidation of Tungsten thermal elements and extends their life.
- Continue venting until the door opens
- Turn OFF the power switch
- Now, open the chamber and take out the coated sample.

Hint

- You can use sources of different type and shape (Filament or Crucibles) or different materials Tungsten, Tantalum or Molybdenum according to VCM 600 Heating Power specifications (400 A, 6V).
- It is recommended to use TWO tools simultaneously, to change the heating element. One to Hold the Feed through and one to operate the top screw.

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Rack type vacuum evaporator

Cleaning

To clean the Base Plate and other parts of the chamber, please use ISOPROPYL ALCOHOL on a soft cloth with no residuals.

SERVICE

ONLY CERTIFIED PERSONNEL CAN HAVE ACCESS TO VCM 600 PARTS

The SERVICE of all parts has to be done according to instructions in the supplied manuals

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Specifications

High Vacuum Generation

- TURBO Pump 300 l/sec
- TURBO Pump Controller with full informative display
- TURBO protection well

Low Vacuum generator

HiScroll 6, DRY pump, 100 l/min, **1.5 x 10 EXP(-2) mbar**

Vacuum Measurement System

- Pirani – Cold Plasma Compact Measuring Head (1000 - 5.0 x 10⁻⁹ hPa)

Vent Valve

- Variable Leak Valve, Manual type

Heating Power Source

- 4x Thermal sources High Temperature (max 1800 Celsius)
- 2x Thermal sources selection switches
- 2x High Current AC power supply max 400A
- 2x Soft SCR current control, 2x digital current measuring instruments
- 8x High Current OFHC Copper Feed through water cooled

Thickness monitoring system

- SQM 160 controller (Inficon) with ONE quartz crystal head (water cooled)

Shutters

- ONE Electromagnetically controlled

Substrate cooling

- Water cooling

Substrate rotation

- Electronically controlled system, 0-40 rpm, manually adjusted

General

- Leak Tested : He Leak Detector down to 2.3 X 10 EXP(-8) mbar . l /s
- Power line : 220V / 50Hz/ 2500W / 3000W
- Water line : Maximum 3 bar, Typical 1,5 bar
- Temperature : +10 to +30 Celsius



tecuum
applied vacuum technology



Tecuum AG
applied vacuum technology



Gertrudstrasse 1
8400 Winterthur, Switzerland
+41 52 508 58 12
sales@tecuum.com, www.tecuum.com